

In re application of: Jong-won LEE et al.

Serial No.: 09/899,627

Group: Art Unit 2822

Filed: July 5, 2001

Examiner: Guerrero, Maria E.

For: SOLUTION FOR CHEMICAL MECHANICAL POLISHING AND METHOD OF
MANUFACTURING COPPER METAL INTERCONNECTION LAYER USING THE SAME

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria VA 22313-1450

AMENDMENT TRANSMITTAL FORM

Sir:

Transmitted herewith is an amendment in the above-identified application.

- [] Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.
[] A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.
[X] No additional fee is required.

The fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	(Col. 3)	SMALL ENTITY	OTHER THAN SMALL ENTITY
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE
TOTAL	17 *	MINUS 20**	= 0 X	9	\$ 0
INDEP.	2 *	MINUS 3***	= 0 X	44	\$ 0
[] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM			X	150	\$ 300
	TOTAL				OR TOTAL \$ 0
	ADDIT. FEE				\$ 0

*If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

** If the "Highest No. Previously Paid for" IN THIS SPACE is less than 20, enter "20".

*** If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

- [] Please charge Deposit Account No. ____ in the amount of \$____. Two (2) copies of this sheet are enclosed.
[] Please charge fee of \$____ for _____ by Credit Card Payment Form PTO-2038 enclosed herewith
[X] Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. **50-0679**. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. **50-0679** therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

Respectfully submitted,

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David L. Heath
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Attorney for Applicant

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop Amendment, Commissioner for Patents, Alexandria VA 22313-1450 on **October 14, 2004**.

Dated: 10/14/04

David L. Heath
David L. Heath



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jong-won Lee et al. Docket: 8021-55 (SS-14743-US)
Serial No.: 09/899,627 Group Art Unit: 2822
Filed: July 5, 2001 Examiner: Guerrero, Maria F.
For: **SOLUTION FOR CHEMICAL MECHANICAL POLISHING AND
METHOD OF MANUFACTURING COPPER METAL
INTERCONNECTION LAYER USING THE SAME**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

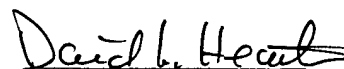
RESPONSE UNDER 37 C.F.R. § 1.111

In reply to the Office Action dated July 15, 2004, please reconsider the above-identified application in light of the following amendments and remarks.

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